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Optimizing operational efficiency and reducing costs of major energy system ... US Pat. 6366889 - Filed May 18, 1999

8 Decision Support System or "System") for analyzing current and historic patterns of energy consumption in a facility to which energy is supplied by one

Gas turbine and steam turbine combined cycle electric power generating plant ... US Pat. 4455614 - Filed Sep 21, 1973 - Westinghouse Electric Corp. This software, including a monitor and I/O handlers, is similar to that ...

Facility management apparatus having touch responsive display screens

Energy extracted from the steam is a function of flow and inlet 35 steam ... US Pat, 5295062 - Filed Jan 18, 1991 - Yamatake-Honeywell Co., Ltd. 4 is a flow chart for explaining an outline of a According to a conventional ... each control monitor point 65 built-in printer, in the facility system and ...

Semiconductor wafer cleaning system

US Pat. 5656097 - Filed Dec 21, 1994 - Verteg, Inc.

At the completion of the Vcl cycle, a modified Vc2 5 factory together with the use of megasonic energy. While the step commences. This dilute HF mixture is ...

Flow metering

US Pat. 6889559 - Filed Apr 26, 2002 - Endress + Hauser Limited 7 to 10, if each of the thermal sensors 29 and 30 is continuously energised so as to continuously monitor thermal losses to the adjacent flow, the energy ...

Air flow monitoring and control system with reduced false alarms US Pat. 7001263 - Filed Aug 6, 2004 - Cornell Research Foundation, Inc. These alarms monitor the air flow in the hood or the ductwork leading to or from the ... systems for monitoring 50 a plurality of fume hoods in a facility. ...

Air cycle air conditioner for heating and cooling US Pat. 5121610 - Filed Oct 10, 1990 - Aisin Seiki K.K. The modifications and operation of the 25 facility are essentially the same as those ... However, if the available energy falls below a factory-set minimum,

Flow metering

US Pat. 7004036 - Filed Apr 6, 2005 - Endress & Hauser Ltd.

7 to 10, if each of the thermal sensors 29 and 30 is continuously energised so as to continuously monitor thermal losses to the adjacent flow, the energy ...

Medical ultrasonic diagnostic system with upgradeable transducer probes and ... US Pat, 5603323 - Filed Feb 27, 1996 - Advanced Technology Laboratories, Inc.



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